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PATENT

I hereby certify that on the date specified below, this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

muary 12,2007

Jennifer A. Steele

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE Certificate

Applicant: Nathan R. Brown

Attorney Docket No.: 500200.02

JAN 3 1 2007

Patent No.: US 6,881,134 B2

of Correction

Issued

: April 19, 2005

Title

: METHOD AND APPARATUS FOR CHEMICAL-MECHANICAL PLANARIZATION

OF MICROELECTRONIC SUBSTRATES WITH A CARRIER AND MEMBRANE

NOTIFICATION OF ERRORS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The following errors were noted in a review of the above-identified letters patent. One of these errors was inadvertently made in the original application, while the others occurred in the printing of the patent. Since the errors are of an obvious nature, a formal Certificate of Correction is not believed to be warranted at this time. Therefore, applicant requests that this notification be placed in the Patent and Trademark Office file.

Column, Line	Reads	Should Read
Column 3, Line 10	"because of the flow of gas"	because the flow of gas
Column 8, Line 18	"appreciated that, although"	appreciated that although

Respectfully submitted,

Date: Jan. 11, 2007

By: Edward W. Bulchis, Reg. No. 26,847

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Enclosure:

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